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a. [Signature]

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT Application of)
Shunpei YAMAZAKI et al.)
Serial No. 09/352,194) Box MISSING PARTS
Filed: July 13 1999)
For: CRYSTALLINE)
SEMICONDUCTOR THIN FILM,)
METHOD OF FABRICATING THE)
SAME, SEMICONDUCTOR)
DEVICE, AND METHOD OF)
FABRICATING THE SAME)



INFORMATION DISCLOSURE STATEMENT
AND NOTIFICATION OF RELATED APPLICATIONS

Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

At least some of the references listed on the attached Form PTO-1449 are

discussed in the specification of the subject application.

Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

The attention of the Examiner is directed to related application Serial Nos. 08/633,307; and 08/928,514.

Respectfully submitted,



Eric J. Robinson
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